

MILLER DECL. IN SUPPORT OF

APPLIED'S MOTION FOR PRELIMINARY

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I, Keith A. Miller, hereby declare as follows:

- 1. I am a Director of Engineering at Applied Materials, Inc. ("Applied") where I have been employed since 1997. I have been in this role for approximately 10 years and am responsible for engineering and design of Applied's physical vapor deposition (PVD) process chambers. Prior to this role, I was an Engineering Manager and Mechanical Engineer at Applied. I either have personal knowledge of the facts contained in this declaration or they are based on research conducted under my supervision and direction. If called upon to do so, I could and would testify competently to the matters set forth herein.
- 2. I submit this declaration in support of Applied's Reply in Support of Its Motion for a Preliminary Injunction.
- 3. I understand that Demaray LLC ("Demaray") has filed patent infringement suits against Applied's customers, Intel Corporation ("Intel") and multiple Samsung entities (collectively, "Samsung") in the Western District of Texas, and has identified Applied's Endura product line (specifically "reactors that can be configured for deposition of TaN layers (e.g., CuBS RFX PVD with the Encore II Ta(N) barrier chamber) and TiN (e.g., Cirrus ionized PVD chamber)" in its complaints against Intel and Samsung.

5. Applied's headquarters are located in Santa Clara, California. In addition to Applied's headquarters in Santa Clara, California, Applied has additional facilities around the United States, including in Massachusetts, Montana, and Austin, Texas. Applied also has facilities around the world, including China, various countries in Europe, India, Israel, Japan, Korea, Singapore, and Taiwan.

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I declare unde	r penalty of perjury that the foregoing is true and correct. Executed on
October 9, 2020.	
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000001 9, 2020.	By: Junt A. Mille
000001 9, 2020.	By: Mull A. Miller Keith A. Miller
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